

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:

Hiromichi Ohta, et al.

Application Serial No:  
09/615,883

Filed July 14, 2000

TITLE: LOW-RESISTANCE ITO  
THIN FILM AND METHOD FOR  
MANUFACTURING SUCH A FILM

) Before the Examiner

) Jason Vincent V. de la Peña

) Group Art Unit 1775

) February 13, 2002

**REQUEST FOR EXTENSION OF TIME**Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant's attorney requests that the date for responding to the Office Action mailed August 14, 2001 for the above-referenced patent application be extended three months to and including February 14, 2002. The statutory fee for a large entity of \$920.00 for this request is enclosed herewith. The U.S. Patent and Trademark Office is authorized to charge any deficiency or apply any overpayment credit to Deposit Account No. 23-3030.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

February 13, 2002  
(Date of Deposit)

Vincent O. Wagner  
Name of Registered Representative

Signature

February 13, 2002  
Date of Signature

Respectfully submitted,

By: 

Vincent O. Wagner  
Reg. No. 29,596  
Woodard, Emhardt, Naughton,  
Moriarty & McNett  
Bank One Center/Tower  
111 Monument Circle, Suite 3700  
Indianapolis, Indiana 46204-5137  
(317) 634-3456

COPY OF PAPER  
ORIGINALLY FILED

RECEIVED  
MAR - 7 2002  
TC 1700